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**CONFIRMATION NO. 8431** 

<b>SERIAL NUMBER</b> 09/934,474	FILING DATE 08/23/2001 RULE	C	<b>CLASS</b> 451	GROUP ART UNIT 3723		T UNIT	ATTORNEY DOCKET NO. 50090-334	
Yoshio Hayashi  ** CONTINUING DATA  ** FOREIGN APPLICA	aki, Tokyo, JAPAN; de, Tokyo, JAPAN; <b>A</b> ************************************							
	GN FILING LICENSE	GRANTE	ĒD					
Foreign Priority claimed  35 USC 119 (a-d) conditions wet  Verified and Allowance  Examiner's Algnature Initials			STATE OR COUNTRY JAPAN	SHEETS DRAWING 7		TOTAL CLAIMS 20		INDEPENDENT CLAIMS 2
ADDRESS McDermott, Will & Eme 600 13th Street, N.W. Washington ,DC 2000	•							
<b>TITLE</b> Polishing solution supp semiconductor substra	oly system, method of s te and method of manu	upplying ıfacturing	polishing solu g semiconducte	tion, a or devi	pparatus ce	s for and	meth	od of polishing
FILING FEE FEES RECEIVED No.	: Authority has been gi	uthority has been given in Paper to charge/credit DEPOSIT ACCOUNT			☐ All Fees ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of time) ☐ 1.18 Fees (Issue) ☐ Other ☐ Credit			